



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Joichi NISHIMURA, et al.

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SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Asst. Commissioner for Patents, Washington, D.C. 20231, on March 15, 2002

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Name of applicant, assignee or Registered Representative

Signature

March 15, 2002

Date of Signature

MM:sds Enclosures Respectfully submitted,

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